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A Facile Method for Permanent and Functional Surface Modification of Poly(dimethylsiloxane)

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Poly(dimethylsiloxane) (PDMS) is the choice of material for a wide range of applications,1-3 because PDMS has many advantageous properties such as chemical inertness, nontoxicity, ease of handling, and commercial availability. It is impossible, however, to have one material that meets all the individual needs of microfluidic systems,¹ micro-electromechanical systems (MEMS),² and cellular study.³ New materials have been developed to replace PDMS. For example, a photocurable perfluoropolyether (PFPE) was synthesized to fabricate microfludic devices that were organic solvent compatible.^{4,5} In a consensus, it is costly to develop a new elastomer for each individual need. And we believe surface modification of PDMS will be a cost-effective and time-saving strategy, if a facile method for surface modification can be developed, since surface modification retains the desired bulk properties of PDMS and reveals the need for new material development.

A number of strategies have been developed for PDMS surface modification, which can be divided into two categories, namely physisorption and chemical coupling. Physisorption of materials to PDMS surface, such as surfactants⁶ and polyelectrolytes⁷ are driven by hydrophobic force and electrostatic force, respectively. This simple method ensures PDMS based devices after modification perform well in situations that only require moderate density and thickness of coatings, and only to sustain low shear force.

Chemical coupling is stable but is difficult to achieve because PDMS is chemically inert, which is ironically one of its merits. Common for this approach, the first step is to apply high-energy bombardment (i.e., plasma) to PDMS surface, which results in a silicate layer with functional groups on the surface, such as -OH and -NH₂. Those functional groups not only render the surface hydrophilicity but also allow further modification via chemical coupling.⁸ Chemical coupling has two problems: (1) Plasma treatment is easy but not sustainable; recovery of hydrophobicity of treated PDMS is well documented.⁹ High-energy bombardment also has the tendency to damage PDMS. Furthermore, this strategy is only applicable to planar structure because of its limited penetration depth. (2) Concentration gradient in "grafting to" strategy prevents the preparation of thick and dense films.¹⁰

We reported herein a facile method for permanent and functional surface modification of PDMS based on a commercial material. First, a vinyl-terminated initiator (v-initiator, part C in Scheme 1) was mixed with the viscous base and curing agent of Sylgard 184, resulting in an initiator integrated PDMS (iPDMS). The base is a poly(dimethyl-methylvinylsiloxane) prepolymer with small amount of platinum (Pt) catalyst (part A in Scheme 1) and the curing agent is a mixture of vinyl-endcapped PDMS precursors and poly-(dimethyl-methylhydrogenosiloxane) precursors as cross-linkers (part B in Scheme 1). Upon mixing together (the so-called curing Scheme 1. Preparation of iPDMS and Permanent Surface Mondification of iPDMS via SI-ATRP



process), the vinyl groups and the hydrosilane hydrogens undergo a hydrosilylation reaction in the presence of Pt catalyst, which results in highly cross-linked three-dimensional networks.

It is a common practice to tune the mechanical property of PDMS by varying the ratio between A and B.¹¹ We reasoned that although the attachment of initiator to cross-linkers would evidently decrease the degree of cross-linking, one could introduce enough v-initiators into the network but only cause limited property change (i.e., mechanical property) by carefully choosing the ratio of A/B/C. In fact, as a random cross-linking process, the network formation is not perfect even without component C and there is always a small amount ($\leq 5\%$, w/w)¹² of unreacted functional groups left.

We found that below a critical ratio of 10:1:0.5 (A/B/C) the mixture cured as regular PDMS (Young's modulus E ~2.12 MPa, contact angle $\theta \sim 112^{\circ}$) and the resulting iPDMS (E ~ 2.05 MPa, $\theta \sim 114^{\circ}$) was successfully used in replica molding. The key for successful surface modification was whether v-initiators would be presented at the surface. X-ray photoelectron spectroscopy (XPS) was applied to characterize the surface composition of iPDMS. Fresh iPDMS was extracted thoroughly with organic solvents to remove unreacted oligosiloxanes and trapped v-initiators.¹² Survey scans of iPDMS showed a v-initiator unique Br 3d peak at 71 eV (Figure 1A). Three-dimensional XPS scans provided more information on the distribution of initiators in iPDMS: the X-Y plane was characterized via sequential point-scan of a 3×3 square (9 points, step of 1 mm). The calculated and experimental atomic concentrations (atom %) agreed well for both PDMS and iPDMS for Si, C, and O (Table 1). The value of atom % for Br was lower than the

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Figure 1. XPS confirmed the surface presentation of the vinyl-terminated initiator in iPDMS. (A) survey scans of PDMS (the gray curve) and iPDMS (the black curve, shifted in *X*-, *Y*-axes): CPS, counts per second; BE, binding energy. (B) XPS depth profile via etching for iPDMS.

Table 1. XPS Confirmed Uniform Surface Distribution of Initiators on iPDMS

	A/B/C		atom % ^d			
	(mass ratio)		Si	С	0	Br
PDMS iPDMS	10/1/0 10/1/0.5	$calcd^a$ $exptl^b$ $calcd^c$ $exptl^b$	$25.0 \\ 27.2 \pm 0.1 \\ 23.9 \\ 26.7 \pm 0.1$	$50.0 49.4 \pm 0.1 51.7 50.4 \pm 0.2$	$25.0 \\ 22.4 \pm 0.1 \\ 24.1 \\ 22.8 \pm 0.1$	0.3 0.1

^{*a*} Atom % was calculated using (SiOC₂) as the repeat unit. ^{*b*} Data averaged from 9 points, \pm standard error. ^{*c*} The M_w for part A + B and part C were 74 and 305, respectively. ^{*d*} Atom % was based on the survey scan of Si 2p (102 eV), C 1s (285 eV), O 1s (532 eV), and Br 3d (71 eV).

calculated value, which was attributed to the photobleaching effect of XPS on Br element and the loss of initiators during the curing process.

The Z-directional scans were accomplished via in situ etching of iPDMS surfaces (Figure 1B). The etching speed was \sim 5 nm/ min. Depth profiles of both PDMS and iPDMS concurrently showed the highest values of Si and O, and the lowest values of C after 1 min etching. Interestingly, the highest atom % for Br appeared at 300 s, which indicated that v-initiators were enriched at \sim 25 nm below the surface. We could not exclude this enrichment was an artifact due to the vacuum process or Argon gun etching. Nevertheless, after this region of notable variations, the atom % of all three major components reached a steady state. For PDMS, the atom % for O, Si, and C were reasonably close to the calculated values (Table 1). For iPDMS, the atom % for O, Si, and C were 26%, 27%, and 45%, respectively. The v-initiator unique element, Br, had an atom % of 0.5%. This small difference between the calculated and experimental values could be attributed to experimental error, or deviations of the final ratio of A/B/C in iPDMS network from the feed ratio of A/B/C, especially when an extraction process was applied to remove unreacted precursors. Besides Sylgard 184 from Dow Corning, RTV 615 from GE and ELAS-TOSiL RT 601 from WACKER were also tested to be compatible with this iPDMS method.

Next, we carried out SI-ATRP of two representative monomers from iPDMS for permanent and functional surface coatings, namely oligo(ethylene glycol)methyl methacrylate (OEGMA) and 1*H*,1*H*,2*H*,2*H*perfluorodecyl methacrylate (FMA). OEGMA was chosen for its demonstrated ability in improving the biocompatibility of PDMS, which was the key for the success of many bioMEMS devices.^{1,3} FMA was commonly used to create surfaces with ultralow surface energy.¹³ In Figure 2A, the characteristic F 1s peak at 690 eV clearly indicated the success of polymerization and film deposition (~28 nm after 1 h SIP, $\theta \approx 128^{\circ}$). The atom % for poly(FMA) coated iPDMS were (O) 7.1%, (Si) 1.9%, (C) 40.9%, (F) 49.9%, and (Br) 0.2%, respectively, which were very close to theoretical values:



Figure 2. XPS confirmed successful surface modification from iPDMS via SI-ATRP: (A) survey scan of poly(FMA) coating, and (B) poly(OEGMA) coating. Inserted were the core scans of F 1s and C 1s.

(O) 6.7%, (C) 36.7%, and (F) 56.7%. Surface grafting of OEGMA did not give such a distinct XPS signal but there was a significant atom % change due to the addition of poly(OEGMA) coating (~50 nm after 2 h SIP, $\theta \approx 48^{\circ}$): (O) 66.4%, (Si) 5.1%, and (C) 28.5% (Figure 2B), which were also close to theoretical values: (O) 66.7% and (C) 33.3%.

Initiators of different structures have been immobilized onto PDMS surfaces by physisorption¹⁴ and chemical coupling.¹⁵ The iPDMS approach differentiates itself from the aforementioned approaches in that v-initiators are covalently integrated into the PDMS networks by a simple mixing procedure, which allows the permanent modification of intact microfluidic channels.

In conclusion, we demonstrated a simple yet effective method to realize permanent and functional surface modification of PDMS. The herein method relies on the creation of iPDMS and subsequent SI-ATRP from iPDMS, which renders PDMS tunable surface properties, for example, from very hydrophilic to very hydrophobic. This combination of iPDMS and SI-ATRP makes possible the application-directed surface modification of PDMS. And we believe this cost-effective method will improve the advancement of bioMEMS, microfluidics, and chips for cellular studies, where surface properties of PDMS plays an important role.

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Supporting Information Available: Experiment details. This material is available free of charge via the Internet at http://pubs.acs.org.

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